



FLOATING CATALYST CVD SYNTHESIS OF SWNTs – LENSSONS EARNED AND FUTURE DIRECTIONS

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Content

- Status SWNT thin film transparent conductors (TCFs) and Thin Film Field Effect Transistors (TFT-FETs) via Direct Dry Deposition from FC-CVD reactor
- TEM of active catalyst particles correlation of particle and tube diameters ?
- Comparison of (n,m) Distributions of SWNTs from Arc Discharge, Laser Vaporization and both Supported and Floating catalyst CVD & steps forward



Aalto University Novel dry, direct CNT film deposition method: <u>DPP</u> – <u>Direct Dry Printing</u> Industrial manufacturing – Canatu Oy **Synthesis** Thin Films Deposition SWCNTs in the reactor gas **Control of SWCNT** Patterned/nonproperties patterned HUT NanoMaterials Group 5 mNanoMaterials Grou

Record performance level of SWCNT-based transparent electrodes (1.7 nm tubes)





94%

96%

98%

100 Ω/□

150 Ω/□

300 Ω/□

Carbon Nanobuds®

increase display contrast

INTU	
he Future	des stir es films





Touch the Future Transparent conductive films for flat, flexible or formable touch devices

aevice

 $\sim \wedge$

0,20%

0,20%

0.20%

CNB[™] haze
 Canatu is a leading manufacturer of transparent conductive films for an entirely new class of touch applications. Canatu's CNB[™] films are based on a new type of carbon nanomaterial (Carbon NanoBud®), and a new Roll-to-0,15%
 Roll manufacturing process (Direct Dry Printing®), which combines the synthesis of the Carbon NanoBuds directly from carbon gases and direct deposition to the substrate in one single process. Canatu offers its customers in consumer electronics and automotive industry next level of design freedom with its innovative technologies.



Canatu's CNB[™] transparent conductive films are designed for demanding touch sensors, paving the way for high-contrast touch displays also in flexible, foldable and 3D format.

Canatu's high-quality CNB[™] films serve touch module and display companies in the rapidly-expanding markets of mobile phones, tablets, cameras, wearable consumer devices, white goods, home appliances and automotive. Canatu also supplies CNB[™] touch sensors for touch module prototyping and small to medium volume production.

Canatu can help electronics hardware companies and brand names who are seeking ways to differentiate products, reduce production costs and increase product performance. Existing materials such as silicon, metals and metal oxides are expensive, not flexible, stretchable or transparent, and require complex and bulky support structures. Moreover, these traditional technologies are reaching their performance limits. With Canatu's CNB™ films it is possible to replace Indium Tin Oxide (ITO) in capacitive touch sensors using existing driving electronics.



Canatu to talk at High Value Manufacturing Graphene Conference 2013

Canatu releases new transparent conductive films with ultra-low reflections and record flexibility

Canatu has been invited to talk about flexible touch sensors in the upcoming global trade events

Canatu to showcase and launch Generation 5 Carbon NanoBud® films in FPD International 2013

Canatu will give a talk on advanced printed touch sensors at the ICFPE conference in Korea

Canatu Ltd: 96% T @ 150 Ohm/□ for PET+CNT film => 97% T @ 150 Ohm/□ for SWNT film only. Stability: T240 h @ 60°C/ 90%RH with < 20% variation of sheet resistance



Simplified resistance model for SWNT network





Tube-to-tube contact resistance as well along tube resistance measurement of pristine SWNTs with conductive atomic force microscope (C-AFM)

The junction resistance versus interfacial area. d1 = tube 1 diameter D2= tube 2 diameter.



The effect of acid doping on a) resistance per unit lenght and b) junction resistance



Dissolve Filter (DF): High mobility & large on/off ratio **CNTN-FETs** by better controlling **SWCNT** bundle length, orientation and SWCNT chiral distribution (Sun, Zavodchikova, Tian, Nasibulin, Kauppinen, Kishimoto, Mitzutani & Ohno (2011), Nature Nanotechnology)



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High performance carbon nanotube TFTs - High mobility (thin film capacitance model) and high on/off achieved concurrently



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Floating Catalyst Methods for CNT Synthesis



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TEM of short SWNTs with Fe catalyst particles made from CO with HWG FC-CVD reactor 2002 200 kV, no heating prior imaging



TEM of SWNTs with Fe catalyst particles made from CO with HWG FC-CVD reactor 2003 200 kV, no heating prior imaging





Ratio between diameters of catalyst particles and CNTs

Pre-made Fe particles introduced in conditions of CNT formation

Experiment	al conditions	Ratio		H_2		D _{CNT,}	D _{Fe} ,			
t _{furn} , °C	O_{CO} ,	D_{part}/D_{CNT}		concentratio	on	nm	nm	D_{part}/D_{CNT}		
Jurn	$Q_{CO},$ cm ³ /min	pari CNI		0.07		1.4	2.1	1.50		
1000	400	1.60		7		1.3	2.1	1.62		
1200	400	1.57		100		1.3	2.0	1.54		
1200	590	1.57		Ethanol, <i>t_{furn}=</i> 1200 °C:						
1200	765	1.52								
1400	400	1.62			$D_{CNT} = 1.7 \text{ nm}, D_{Fe} = 2.4.$ $D_{part}/D_{CNT} = 1.41$					

In-situ CVD Synthesis of Particles :

Ferrocene vapor decomposition in CO at 1150 °C $D_{CNT} = 1.3 \text{ nm}, D_{part} = 3.1 \text{ nm}$ $D_{part}/D_{CNT} = 2.4$ MORE DETAILS LATER

HiPco CNTs (Nikolaev *et al.* ChemPhysLett 1999) $D_{CNT} = 0.7-1.4 \text{ nm}, D_{part} = 5-10 \text{ nm}$ $D_{part}/D_{CNT} > 3$

Catalyst formed in-situ during ferrocene decomposition in **CO/CO**₂ – catalyst nucleation & growth and SWNT nucleation coupled. Moisala et al., CES 2006

Ferrocene decomposition slow – overlapp between CNT nucleation & growth and cerrocene decomposition – CVD growth of Fe clusters



Floating Catalyst Methods for CNT Synthesis



Optical absorption derived SWCNT diameter distributions vs. wall temperature and vs. CO₂ concentration



Catalyst particle size distribution in SWNTs produced with ferrocene reactor. SWNT mean diameter about 1.3 nm.



Cs-corrected TEM images of SWCNTs

Sample: **Ferrozen** 1000 C with CO + H_2O Collected on TEM grid via ESP filter

Microscope: **FEI Titan™ 80-300** High tension (HV): **80 kV**

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Active catalyst is larger than the tube



Cs-corrected TEM images of SWCNTs

Carbon atoms

Microscope: **FEI Titan™ 80-300** High tension (HV): **80 kV**

> Large Non-active Catalyst Particles

Sample: Ferrozene Reactor 1000 C with CO + H_2O Collected to TEM grid via ESP filter





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Chiral angle distributions for a SWCNT sample produced by arc discharge¹



Chiral angle distribution of 124 individual SWNTs characterized experimentally by nano-beam electron diffraction analysis.

The histogram shows normalized number (normalized by dividing the observed number of nanotubes by the number of nanotube species at each helicity) of characterized individual nanotubes with different helicities.

-- Qin et al., *Phys. Rev.* **B 71**, 245413 (2005)

1. C. Journet, W. K. Maser, P. Bernier, A. Loiseau, M. Lamy de la Chappelle, S. Lefrant, P. Deniard, R. Lee, and J. E. Fischer, Nature (London) **388**, 756 (1997).

Arc SWNTs



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Chiral angle distributions for a SWCNT sample produced by laser ablation²



Chiral angle distribution for a laser-ablation SWCNT sample. The measurement was based on **electron diffraction analysis** of 48 SWCNT bundles and 10 individual SWCNTs which results in a total occurrence of 228 helicities for statistic.

-- Jiang et al., Appl. Phys. Lett. 93, 141903 (2008)

2. T. Guo, P. Nikolaev, A. Thess, D. T. Colbert, and R. E. Smalley, Chem. Phys. Lett. **243**, 49 (1995).

Laser SWNTs (optical)







Alcohol SWNTs (PL – did not find ED)



New Journal of Physics 5 (2003) 149.1–149.12



Sergei M. Bachilo,Leandro Balzano, Jose E. Herrera, Francisco Pompeo, Daniel E. Resasco and R. Bruce Weisman J. AM. CHEM. SOC. 2003, 125, 11186-11187.

19.1

0.0

4.6

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10.5

1.050

TEM/ED individual tube data - Jiang et al. unpublished

Chirality i.e. (*n,m*) maps for samples produced with (a) 0 ppm NH3, and (b) 500 ppm NH3 as determined with electron diffraction of individual SWCNTs – *large chiral* angle due to enhanced etching of low chiral angle tubes





Jiang et al., JACS 133, 1224 (2010)

Chiral angle distributions for the NIST VAMAS TWA-34 SWCNT sample (CoMoCAT)³



Chiral angle distribution for a CoMoCAT SWCNT sample. The measurement was based on **electron diffraction analysis** of 44 SWCNT bundles and 49 individual SWCNTs which results in a total occurrence of 269 helicities for statistic.

-- Jiang et al., unpublished (2010)

3. Provided by NIST VAMAS TWA-34 project.

Chiral angle distributions for a SWCNT sample produced from CO by a floating catalyst (aerosol) CVD process

introduced with 0 ppm NH₃ (blue)



Chiral angle distribution for a SWCNT sample produced without NH₃ introduced. The measurement was based on electron diffraction analysis of totally **95** individual SWCNTs. *CO flow rate@400 cm³/min, CO2 flow rate@2 cm³/min, Temperature@ 880 °C*

-- Jiang et al., JACS 133, 1224 (2010)

Chiral angle distributions for a SWCNT sample produced from CO by a floating catalyst (aerosol) CVD process

introduced with 500 ppm NH₃ (Red)



Chiral angle distribution for a SWCNT sample produced with 500 ppm NH₃ introduced. The measurement was based on electron diffraction analysis of totally **108** individual SWCNTs. *CO flow rate@400 cm³/min, CO2 flow rate@2 cm³/min, Temperature@ 880 °C*

-- Jiang et al., JACS 133, 1224 (2010)

Characterization of SWNTs grown at 500 C, 1 atm

Co-MgO II by impregnation



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Chiral angle distributions for a SWCNT sample grown on lattice-mismatched epitaxial Co Nanoparticles



Chiral angle distribution for a Co grown SWCNT sample (500 °C). The measurement was based on **electron diffraction analysis** of 57 individual SWCNTs.

-- He et al., Scientific Reports 3, 1460 (2013)









Lattice-mismatched epitaxial Co on MgO CO @ 1 atm, 500 oC



Peking U. Prof. Y. Li with faceted catalyst: close to just one (n,m) ?



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- * EU FP7 TREASORES &
- **IRENA** projects
- * Aalto MIDE and AEF programs

Indium **Re**placement by Single-Walled Carbon **Na**notube Thin Films G

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